Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/711,990	FUJISAKI, IWAO	
Examiner	Art Unit	
Suhail Khan	2617	

	SEARCHED					
Class	Subclass	Date	Examiner			
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Tommy Chin, John Peng, Richard Lee and Charles Appiah assisted in Restriction/ Search.	4/17/2006	SK
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